

Notice of References Cited	Application/Control No. 09/975,256	Applicant(s)/Patent Under Reexamination RAMKUMAR ET AL.	
	Examiner David L. Hogans	Art Unit 2813	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,180,543	01-2001	Yu et al.	438/787
	B	US-5,766,994	06-1998	Tseng, Horng-Huei	438/254
	C	US-6,399,520	06-2002	Kawakami et al.	438/778
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Peter van Zant; Microchip Fabrication, 2000; McGraw-Hill; Fourth Edition; pages 156, 160, 188-9, 503 and 513-4.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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